

FRAUNHOFER INSTITUTE FOR
CERAMIC TECHNOLOGIES AND SYSTEMS IKTS

Workshop Registration

Registration for the participation in the 3rd technical workshop on **January 30, 2015** at the Tokyo International Forum, Room 801, Tokyo Big Sight. The workshop is held in English with simultaneous Japanese translation. The participation is free.

Agenda

10 am to 10:30 am	Introduction
10:30 am to 11:15 am	Part I: High-performance screen-print pastes for AlN and Si ₃ N ₄
11:15 am to 12 pm	Part II: From powders, inks and pastes to advanced functional elements

I will take part at the workshop:

male female

Name _____

Surname _____

Position _____

Company _____

Address _____

E-Mail _____

I will bring along an accompanying person:

male female

Name _____

Surname _____

Position _____

Company _____

Address _____

E-Mail _____

Please report back concerning your participation in the seminar until **January 23, 2015** via e-mail to corinna.jaehnic@ikts.fraunhofer.de or via fax to +49 351 2554 244.